

IN THE CLAIMS

Claims 1-13 (Cancelled).

14. (Original) A method, comprising:
positioning a disk, having a hole defined by an inner diameter edge of the disk,
over a nest; and
guiding the disk into close proximity of the nest by directing gas into the inner
diameter hole of the disk.
15. (Original) The method of claim 14, wherein positioning further comprises
admitting gas into a first port to distribute around a manifold of a pickup head that
receives the disk.
16. (Original) The method of claim 15, wherein positioning further comprises
creating a low gas pressure and a positive gas pressure within the manifold to suspend the
disk into close proximity of the manifold.
17. (Original) The method of claim 16, wherein guiding further comprises
transferring gas to a second port coupled to a plurality of gas jets directed towards the
hole of the disk.
18. (Original) The method of claim 16, wherein creating the low gas pressure and the
positive gas pressure produces a Bernoulli effect.
19. (Original) The method of claim 14, further comprising centering the disk within
the nest.
20. (Original) The method of claim 14, further comprising maintaining the gas at an
elevated temperature.

21. (Original) The method of claim 20, wherein the elevated temperature comprises an embossing temperature.

22. (Original) The method of claim 20, further comprises nano-imprinting an embossable film disposed above the disk substrate.

23. (Original) The method of claim 17, wherein transferring gas to the second port further comprises directing gas flow to an inner diameter of the disk.

24. (Original) The method of claim 19, wherein centering further comprises engaging an outer dimension of the disk with a plurality of rods coupled to actuators.

Claims 25-33 (Cancelled).